

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Appl. No. : 10/823,970) Confirmation No. 5318
Applicant : OGAWA, et al.)
Filed : 13 April 2004)
Art Unit : 2818)
Examiner : Hoang, Quoc Dinh)
Attorney)
Docket No. : SPSN-AF01215)
)
For: SEMICONDUCTOR DEVICE HAVING)
A PAD METAL LAYER AND A LOWER METAL)
LAYER THAT ARE ELECTRICALLY)
COUPLED, WHEREAS APERTURES ARE)
FORMED IN THE LOWER METAL LAYER)
BELOW A CENTER AREA OF THE PAD)
METAL LAYER)
_____)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE AND RCE

Dear Sir:

In response to the Office Action dated November 29, 2007, and coincident with the RCE filed herewith, Applicants respectfully request reconsideration of the above-identified patent application. Please consider the following amendments and remarks for allowance of the above-identified patent application. Immediately after this transmittal page are Amendments to the Claims, included in a complete listing of the claims, followed by Applicant Argument (or Remarks).

I hereby certify that this
correspondence is being
electronically transmitted to
the USPTO via EFS on the
date shown below:
February 29, 2008

/Christina R. Holland/
Christina R. Holland